



#10/C
L74801
6/24/03

Docket No.: 122.1422

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of:

Makoto ONOZAWA, et al.

Serial No. 09/702,889

Group Art Unit: 2675

Confirmation No. 8796

Filed: November 1, 2000

Examiner: Fritz Alphonse

For: PLASMA DISPLAY APPARATUS AND MANUFACTURING METHOD

PRELIMINARY AMENDMENT

RECEIVED

JUN 20 2003

Assistant Commissioner for Patents
Washington, D.C. 20231

Technology Center 2500

Sir:

This Preliminary Amendment is filed concurrently with a Request for Continued Examination (RCE).

Before examination of the above-identified application, please amend the application as follows.

IN THE CLAIMS:

Please ADD claims 17-19 as follows:

17. (NEW) The plasma display apparatus, as set forth in claim 1, wherein the first phase adjusting circuit phase-shifts the first driving signal which drives said first output device, and the second phase adjusting circuit phase-shifts the second driving signal which drives said second output device.

18. (NEW) The plasma display apparatus, as set forth in claim 17, wherein:
the first phase shifting circuit comprises:

a first output signal detecting circuit to detect an output of the first output device,

and

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cont.